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00684.003279.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Chidane OUCHI

Application No.: 09/986,323

Filed: November 8, 2001

For: EXPOSURE APPARATUS AND DEVICE
MANUFACTURING METHOD USING THE
SAME

Examiner: D. Ben Esplin

Group Art Unit: 2851

April 8, 2003

The Commissioner for Patents
Washington, D.C. 20231

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AMENDMENT WITH PETITION FOR EXTENSION OF TIME

Sir:

Applicant petitions the Commissioner for Patents to extend the time for response to the Office Action dated November 8, 2002, for two months from February 8, 2003, up to and including April 8, 2003. A check in the amount of \$410.00 for payment of the extension fee is enclosed. Please charge any additional fee required for the extension, or credit any overpayment, to Deposit Account 06-1205.

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410.00 OP

INTRODUCTORY COMMENTS

This Amendment has been prepared in accordance with the Revised Format established by the U.S. Patent and Trademark Office, as permitted in the Pre-OG Notice dated February 4, 2003, and entitled "Amendments in a Revised Format Now Permitted."

In response to the Official Action dated November 8, 2002, please amend the above-identified application as follows: